

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants: K. KURODA et al.  
Serial No.: (new divisional application under 37 CFR §1.53[b] of U.S.  
Application Serial No. 09/985,309)  
Filed: December 31, 2003  
For: A SEMICONDUCTOR DEVICE AND A METHOD OF  
MANUFACTURING THE SAME AND DESIGNING THE  
SAME  
Group: 2814  
Examiner: D. FARAHANI

**CLAIM FOR FOREIGN PRIORITY**

**MS: PATENT APPLICATIONS**

Commissioner for Patents  
POB 1450  
Alexandria, VA 22313-1450

December 31, 2003

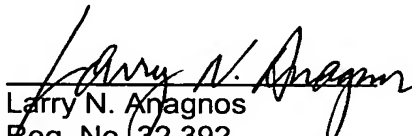
Sir:

Pursuant to 35 U.S.C. §119 and 37 CFR §1.55, applicants hereby claim  
the right of priority based on the following foreign application filed in Japan:

**Application No. 2000-353045, filed November 20, 2000.**

A certified copy of this foreign application was filed on November 2, 2001  
in prior, parent U. S. Application Serial No. 09/985,309.

Respectfully submitted,  
**ANTONELLI, TERRY, STOUT & KRAUS, LLP**

  
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